

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shriram Ramanathan et al.)
Serial No.: 10/611,395)
Filed: June 30, 2003)
For: Methods for Bonding Wafers Using a Metal Interlayer)
Examiner: N. Berezny)
Group Art Unit: 2813)
Attorney Docket No.: P16666)
)

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

This Preliminary Amendment accompanies a Request for Continued Examination (RCE) filed in accordance with 37 C.F.R. § 1.114.

Docket No. P16666 Serial No. 10/611,395

INTRODUCTORY COMMENTS

The following amendments and remarks are proposed in response to the Final Office Action mailed January 7, 2005.

Claims 1-42 were pending in the application, but claims 28-42 have been withdrawn from further consideration. Claims 1-11 and 13-26 have been rejected, and claims 12 and 27 stand objected to. Applicants propose herein to amend claims 1-5, 7-13, 20, 22, 24, and 27. Applicants note that the amendments to each of claims 2-5, 7-12, 20, 22, 24, and 27 was simply to correct matters of form.

Applicants respectfully request reconsideration of the application in view of the amendments set forth herein and the accompanying remarks.